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1765
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of)
John E. Lang) Docket No: LAM2P266
Application No: 09/274,194) Examiner: C. Brown
Filed: March 22, 1999) Group Art Unit: 1765
For: METHOD OF REMOVING PHOTORESIST) Date: July 31, 2002
MATERIAL WITH DIMETHYL SULFOXIDE)

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I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on July 31, 2002.

Signed: _____

Kay Harlow

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Commissioner for Patents
Washington, D. C. 20231

Sir:

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